

Cambridge University Press

978-1-107-41192-0 - Defect and Impurity Engineered Semiconductors and Devices III:

Materials Research Society Symposium Proceedings: Volume 719

Editors: S. Ashok, J. Chevallier, N. M. Johnson, B. L. Soporì and H. Okushi

Copyright Information

[More information](#)

MATERIALS RESEARCH SOCIETY
SYMPOSIUM PROCEEDINGS VOLUME 719

Defect and Impurity Engineered Semiconductors and Devices III

Symposium held April 1–5, 2002, San Francisco, California, U.S.A.

EDITORS:

S. Ashok

The Pennsylvania State University
University Park, Pennsylvania, U.S.A.

J. Chevallier

CNRS
Meudon, France

N.M. Johnson

PARC
Palo Alto, California, U.S.A.

B.L. Soporì

National Renewable Energy Laboratory
Golden, Colorado, U.S.A.

H. Okushi

Electrotechnical Laboratory
Ibaraki, Japan



Materials Research Society
Warrendale, Pennsylvania

Cambridge University Press

978-1-107-41192-0 - Defect and Impurity Engineered Semiconductors and Devices III:
Materials Research Society Symposium Proceedings: Volume 719

Editors: S. Ashok, J. Chevallier, N. M. Johnson, B. L. Soporì and H. Okushi

Copyright Information

[More information](#)

CAMBRIDGE UNIVERSITY PRESS

Cambridge, New York, Melbourne, Madrid, Cape Town,
Singapore, São Paulo, Delhi, Mexico City

Cambridge University Press

32 Avenue of the Americas, New York NY 10013-2473, USA

Published in the United States of America by Cambridge University Press, New York

www.cambridge.org

Information on this title: www.cambridge.org/9781107411920

Materials Research Society

506 Keystone Drive, Warrendale, PA 15086

<http://www.mrs.org>

© Materials Research Society 2002

This publication is in copyright. Subject to statutory exception
and to the provisions of relevant collective licensing agreements,
no reproduction of any part may take place without the written
permission of Cambridge University Press.

This publication has been registered with Copyright Clearance Center, Inc.

For further information please contact the Copyright Clearance Center,
Salem, Massachusetts.

First published 2002

First paperback edition 2013

Single article reprints from this publication are available through

University Microfilms Inc., 300 North Zeeb Road, Ann Arbor, MI 48106

CODEN: MRSPDH

ISBN 978-1-107-41192-0 Paperback

Cambridge University Press has no responsibility for the persistence or
accuracy of URLs for external or third-party internet websites referred to in
this publication, and does not guarantee that any content on such websites is,
or will remain, accurate or appropriate.